



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Smith, *et al.* Docket No.: 2001 P 11900 US01  
Serial No.: 10/786,996 Art Unit: 1746  
Filed: February 25, 2004 Examiner: Markoff, Alexander  
For: Method of Removing PECVD Residues of Fluorinated Plasma Using In-Situ H<sub>2</sub> Plasma

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Dear Examiner:

Applicants respectfully request reconsideration of the claims in view of the following amendments and remarks, which are submitted as a full and complete response to the Examiner's Office Action dated December 30, 2005.